IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Josef Halamik et al

FILED: Concurrently Herewith

FOR: POWER SYSTEM INHIBIT METHOD AND DEVICE AND

STRUCTURE THEREFOR

Date: 10/10/2003

DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.56

Honorable Assistant Commissioner for Patents Washington, D.C. 20231

SIR:

It is respectfully requested that the prior art listed on FORM PTO-1449 be considered in the examination of the subject application and made of record therein. A copy of the listed prior art is enclosed herewith.

No representation is made or intended that the listed prior art enclosed herewith is material to patentability of the subject patent application.

No representation is made or intended that a search has been made or that no better prior art than that listed is available.

Respectfully submitted, Josef Halamik et a,l

Van O 1

Jămes J. Stipanuk Reg. #44,358

Phone: 602-244-4885 Fax: 602-244 3169

Customer

ON Semiconductor

Intellectual Property Dept.

P.O. Box 62890 - A700

Phoenix, AZ 85062-2890

#:

27255

Form PTO-1449

LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE

STATEMENT (Use Several Sheets if Necessary)

ATTY. DOCKET NO.	SERIAL NO.	
ONS00482		
APPLICANT Josef Halamik et al		
FILING DATE	GROUP	
CONCURRENTLY		

DEFER	NIOE.	DECK	マトレスエ	ION

U.S. PATENT DOCUMENTS

Examiner Initial		ocum				r				Date	Name	Class	Sub- Class	Filing date (If approp rirate)
TA/	-		5	4	7	7	1	7	5	12/19/1995	Tisinger et al	H03L	7/00	
AE	3			†	1	1	1						ļ	
AC	5		<u> </u>	 									ļ	
ΑI	5		T		T									
AE	E			T										
AF	=													
A	G 📗								<u> </u>					
Al	H					<u> </u>		<u> </u>	<u> </u>					
Al							<u> </u>		<u> </u>					
A	J						<u> </u>	<u> </u>	<u> </u>					
Al	K						<u> </u>	<u> </u>						
Al	L				<u> </u>				<u> </u>				ļ	
Al	М													

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document #							Date	C	ountry	Class/s	subclass	Trans	lation - No
	AN				-							 			
	AO											 		_	
	AP											 <u> </u>	<u> </u>		
	AQ											 ļ <u>.</u>			
	AR														

AS	
AT	
AU	
AV	
AW	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.